



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 9275

SERIAL NUMBER 10/536,621	FILING OR 371(c) DATE 05/26/2005 RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. UNIU40.005APC
APPLICANTS Masahiko Nakamori, Shiga, JAPAN; Tetsuo Shimomura, Shiga, JAPAN; Takatoshi Yamada, Shiga, JAPAN; Kazuyuki Ogawa, Osaka, JAPAN; Atsushi Kazuno, Osaka, JAPAN; Kimihiro Watanabe, Osaka, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/15128 11/27/2003				
** FOREIGN APPLICATIONS ***** JAPAN 2002-343199 11/27/2002 JAPAN 2003-000331 01/06/2003 JAPAN 2003-029477 02/06/2003 JAPAN 2003-064653 03/11/2003				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 20
Verified and Acknowledged Examiner's Signature _____ Initials _____		INDEPENDENT CLAIMS 1		
ADDRESS 20995				
TITLE Polishing pad and method for manufacturing semiconductor device				
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	